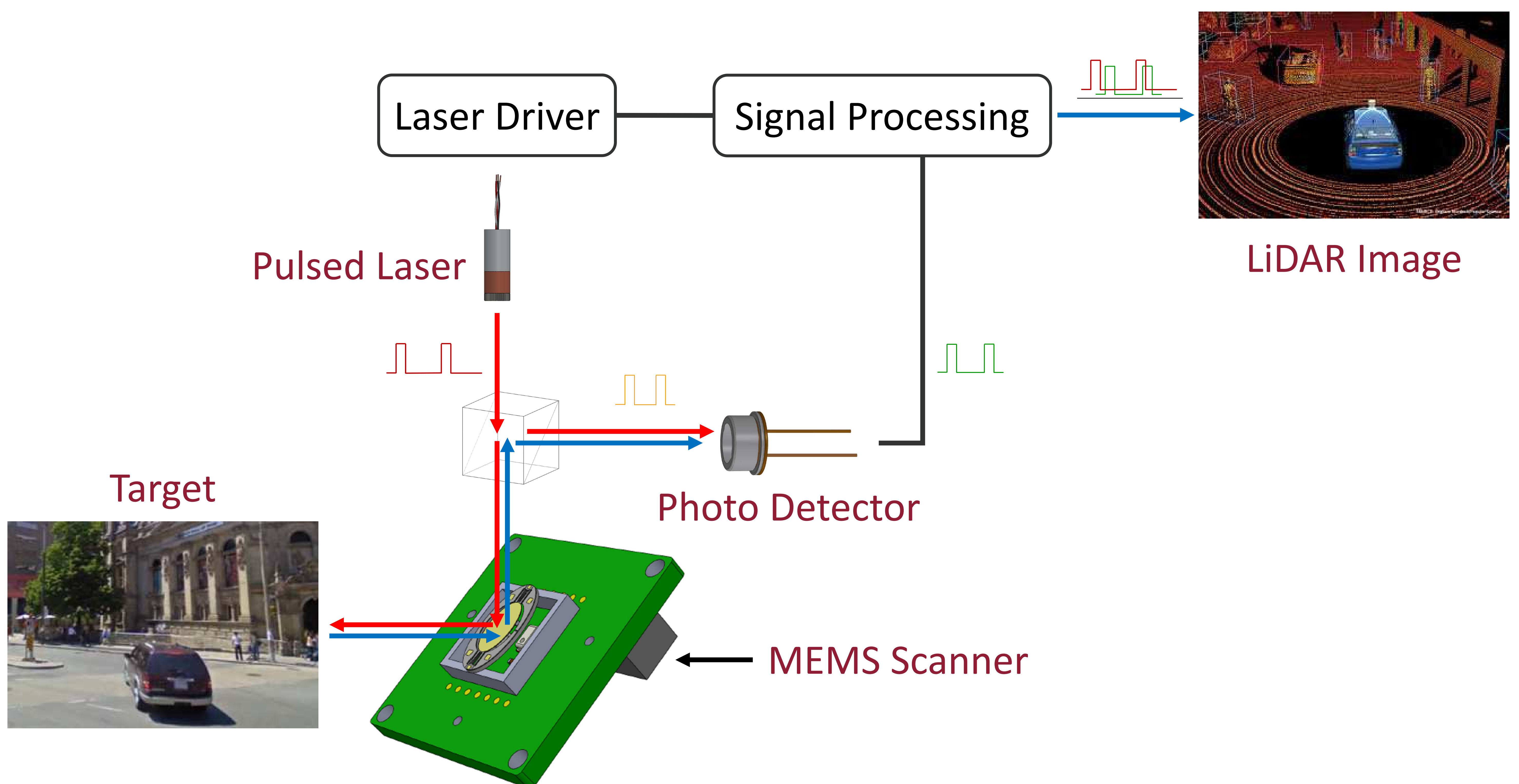


WeMEMS Co. is a proud suppliers of high-speed Si MEMS (Micro-Electro Mechanical Systems) scanners with large mirrors.

● The purpose of the product

- ✓ A Si laser scanner using MEMS technology rotates a reflective mirror adjusting the direction of the incident laser at high speed as a key engine for image sensors for LiDAR or display for AR.
- ✓ MEMS scanner are essential components of autonomous vehicles and drones, whose markets are rapidly expanding.
- ✓ MEMS scanner can be provided with angular position sensors enabling LiDAR to generate more accurate 4D perception data (shape, distance and velocity).

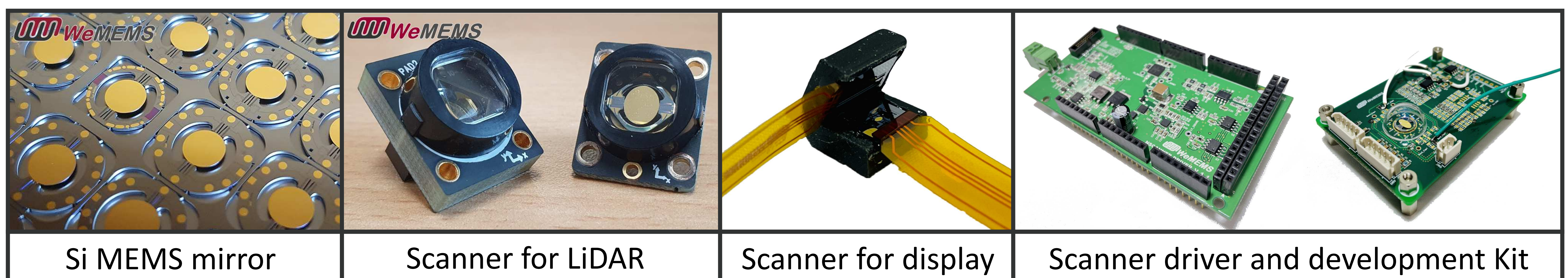


Products lineup

| No. | Product/Service | Operation modes | Mirror size | Driving freq. | Scanning angle | Remarks |
|-----|------------------|--|--------------|---------------|----------------|------------|
| 1 | One-axis scanner | Resonant | 1 ~ 6 mm | 1 ~ 9 kHz | > 40 ° | LiDAR |
| 2 | " | Quasi-static | 3.5 ~ 5.0 mm | 0 ~ 120 Hz | > 25 ° | Biomedical |
| 3 | Two-axis scanner | Resonant | 1 ~ 2 mm | 8 ~ 33 kHz | > 45 ° | LiDAR |
| | | Quasi-static | | 0 ~ 60 Hz | > 18 ° | AR |
| 4 | " | Quasi-static | 1 ~ 4 mm | 0 ~ 120 Hz | > 18 ° | Biomedical |
| 5 | Services | MEMS design and simulation: Mechanical, Electrical, Thermal analysis from chip to PKG level | | | | |

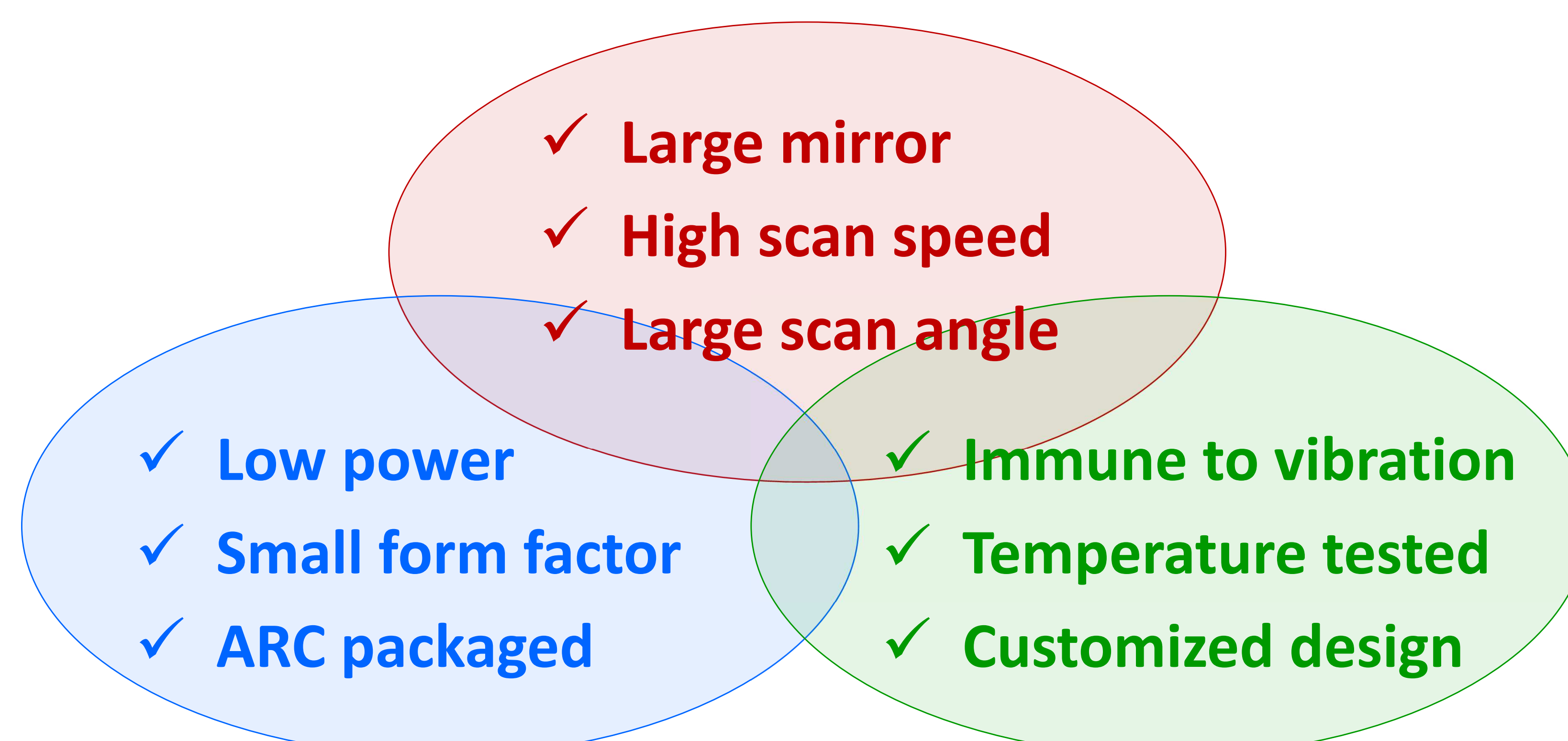
* The specifications are subject to change with no notice.

* Refer to product specifications for details.



Merits of WeMEMS Scanner

- ✓ WeMEMS has successfully developed packaged MEMS scanners employing specially designed structures that has passed rigorous vibration and temperature tests.
- ✓ Since MEMS scanners can meet the expectations for autonomous vehicles, LiDAR manufacturers have been focusing on improving their performance to meet the requirements.

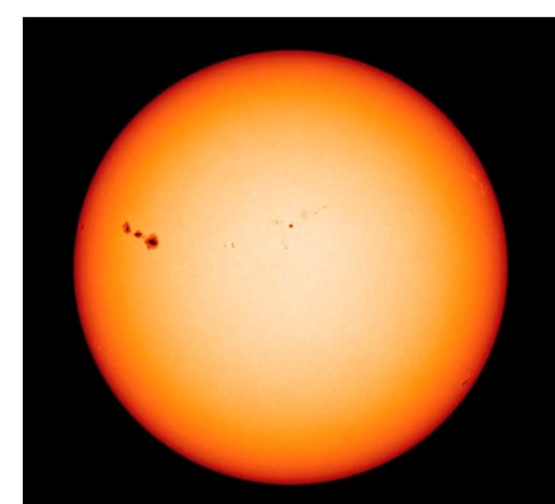


Tunable Spectral Filter

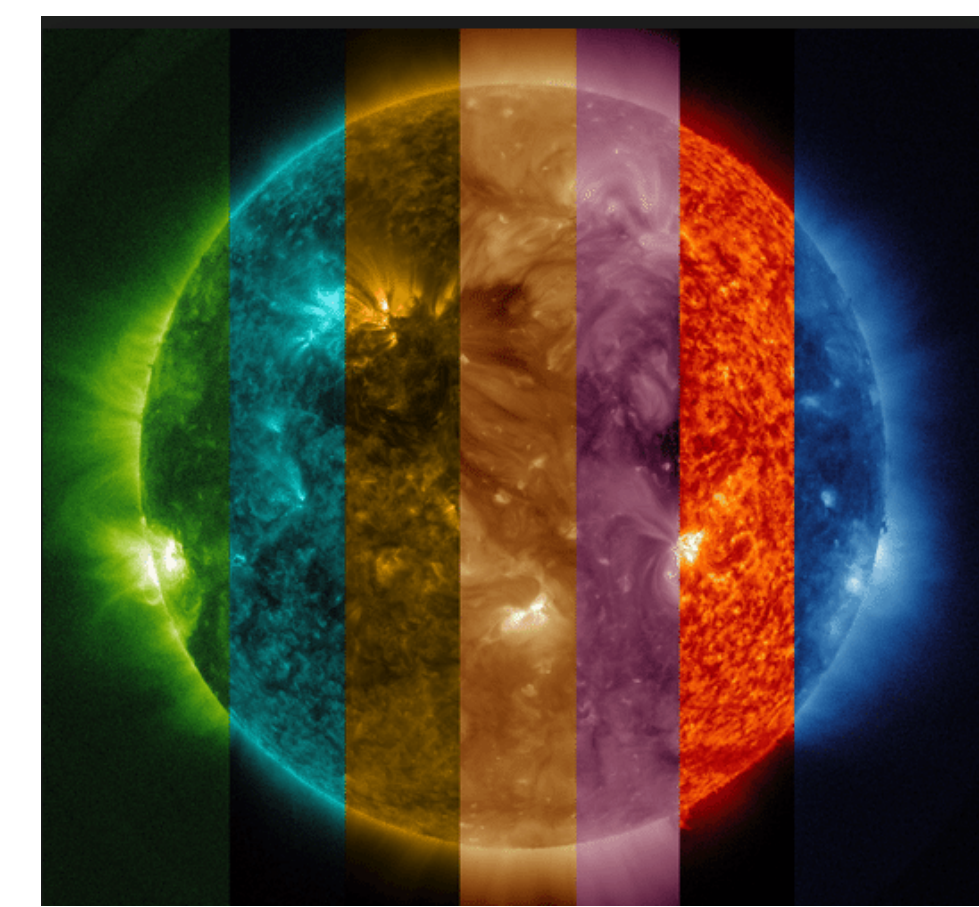
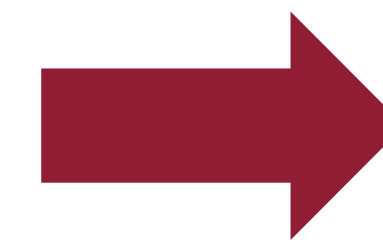
- ✓ Spectral imaging is the acquisition of a spectrum for each pixel in an image of a scene for the purpose of object locating, material identification or process detection.
- ✓ WeMEMS has developed a tunable spectral filter utilizing a fabry-perot cavity.



Tunable spectral filter
(attached on a camera)

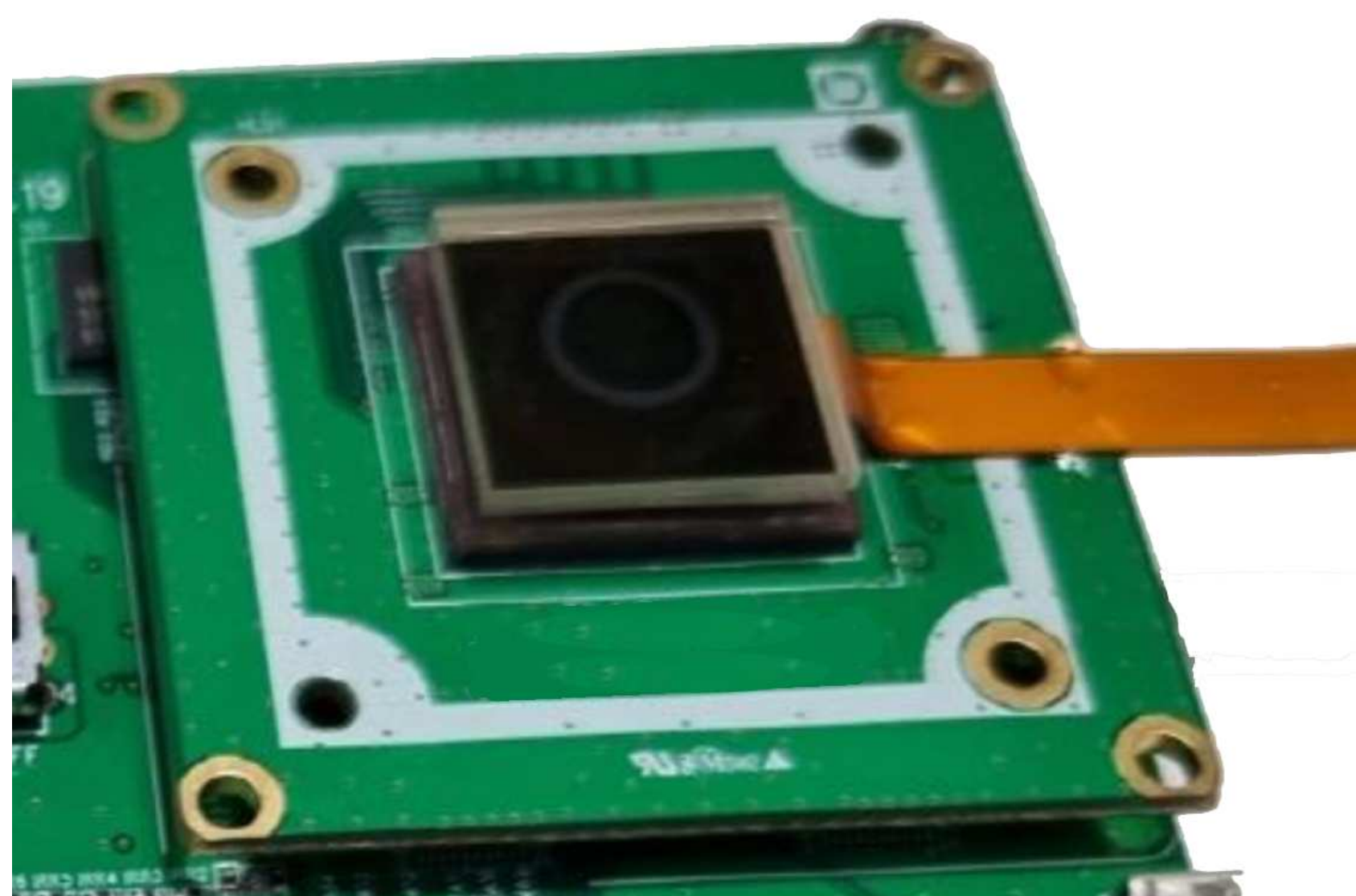


Target

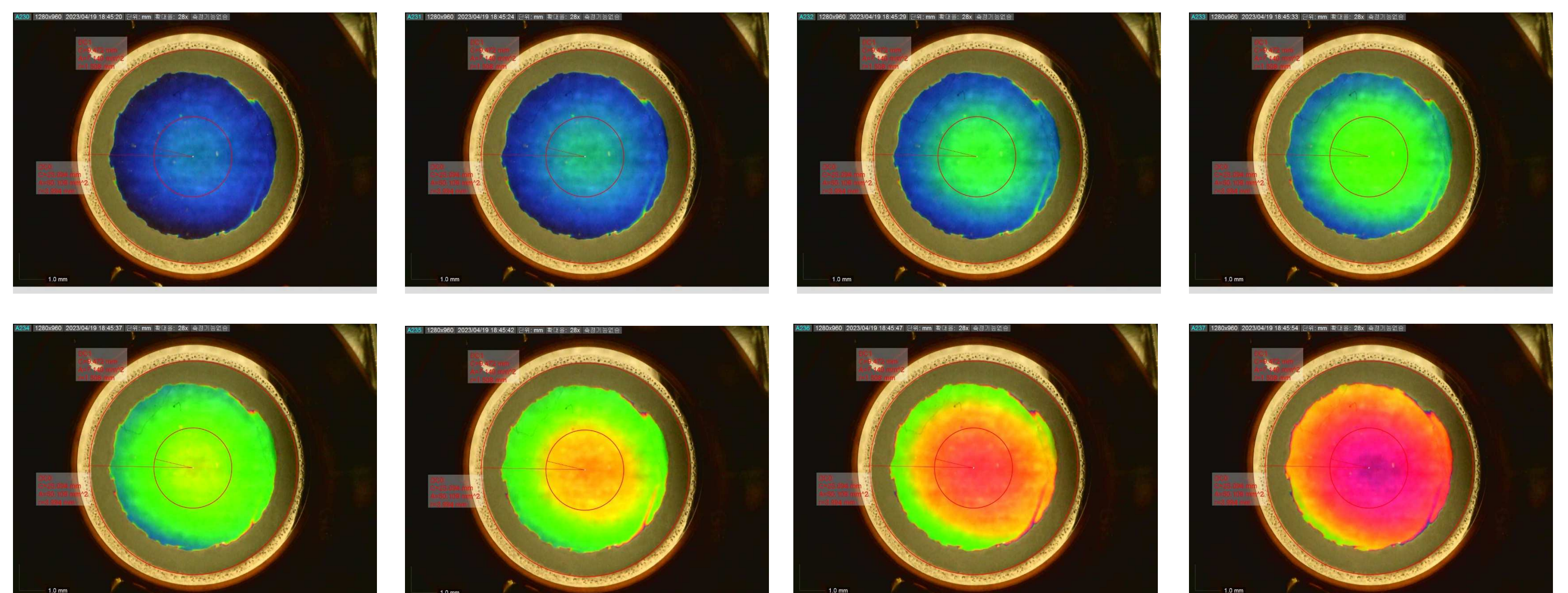


Spectral imaging

Spectral imaging schematic



WeMEMS tunable spectral filter
(w/ image sensor assembly)



Wavelength tuning

Experimental Performance



Imaging

| Parameter | Value |
|-------------------------------|-----------|
| Clear aperture [mm] | ~ 3 |
| Spectral range [nm] | 450 - 700 |
| FWHM [nm] | < 30 |
| Average peak transmission [%] | > 30 |
| Stop-band transmission [%] | < 3 |
| CWL repeatability [nm] | 3.6 |
| Switching time [msec] | < 30 |

2-axis MEMS scanner

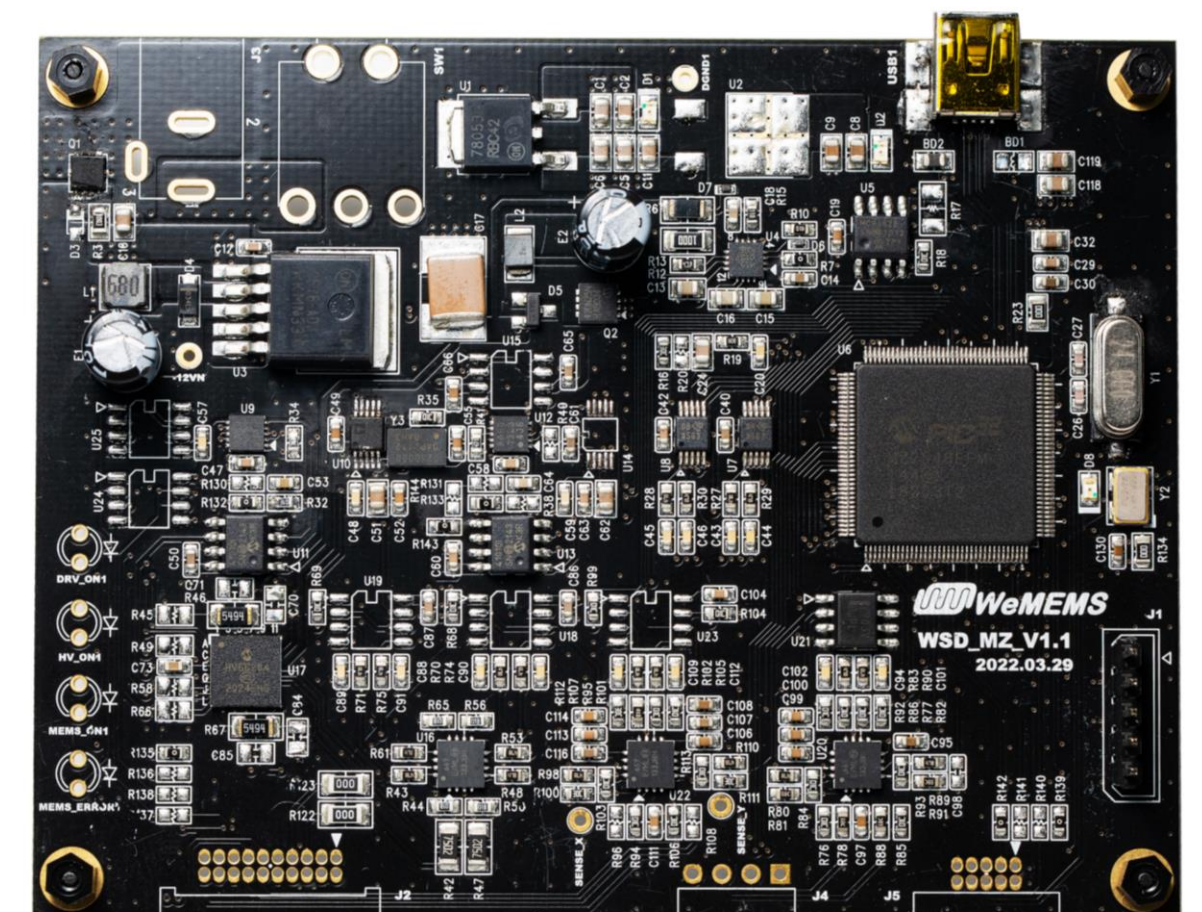
- ✓ A 2-axis gimbaled MEMS scanner was developed using quasi-static and resonant actuators.
- ✓ The 2-axis scanner can control the scanning direction of the laser beam in the LiDAR systems, making it easy to detect the three-dimensional images of the objects.



2-axis MEMS Scanner



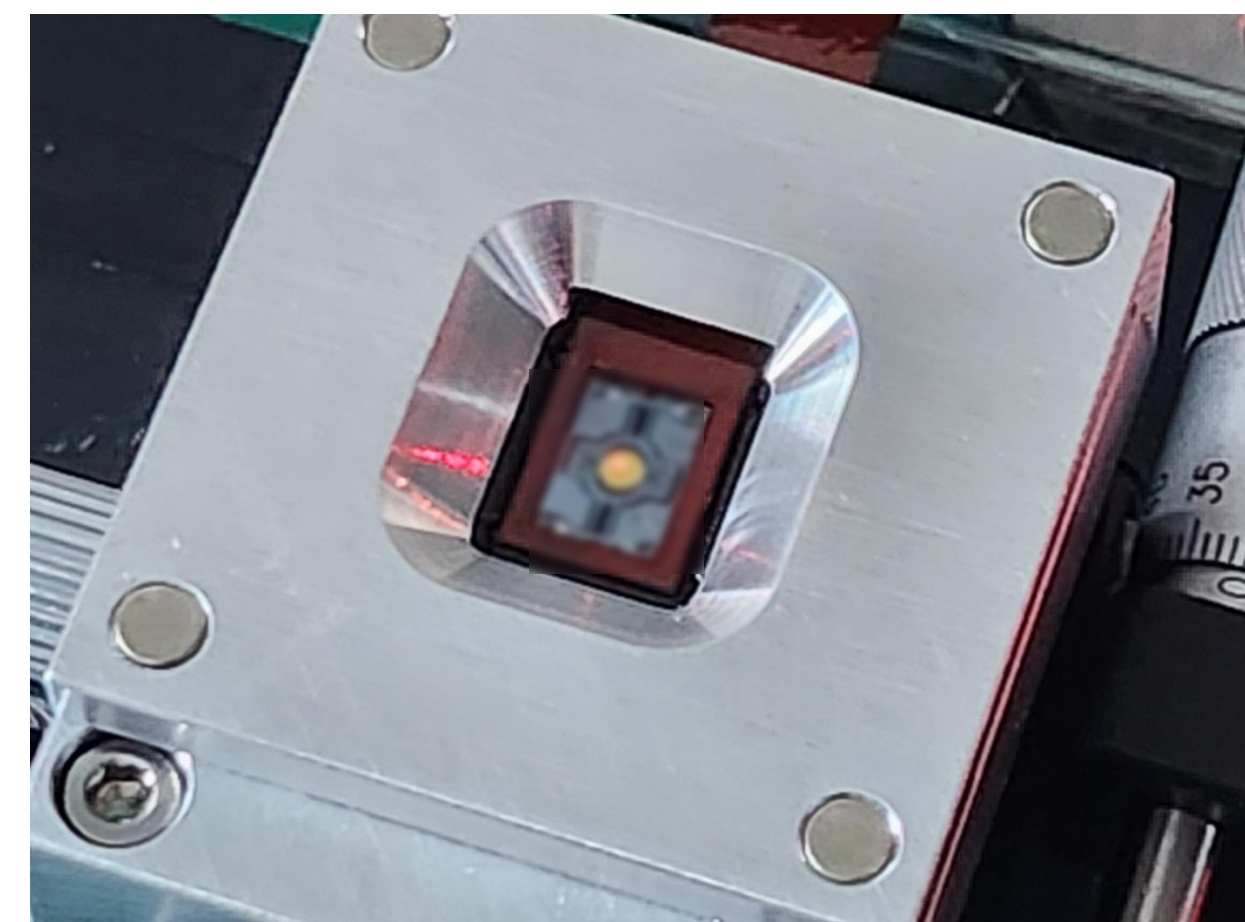
Scanner driver



Experimental Setup

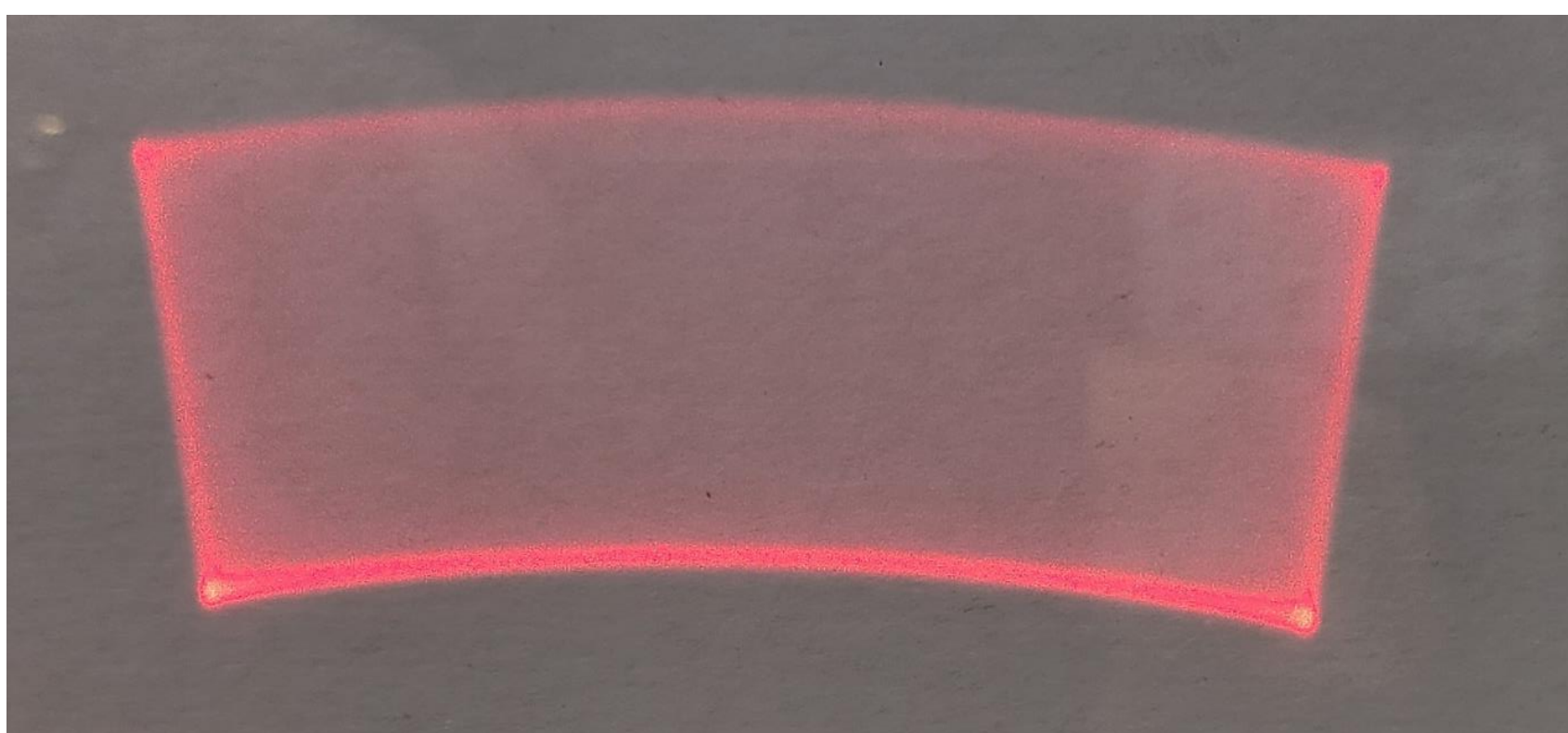


Experimental setup



Laser incidence on the MEMS mirror

Experimental Performance



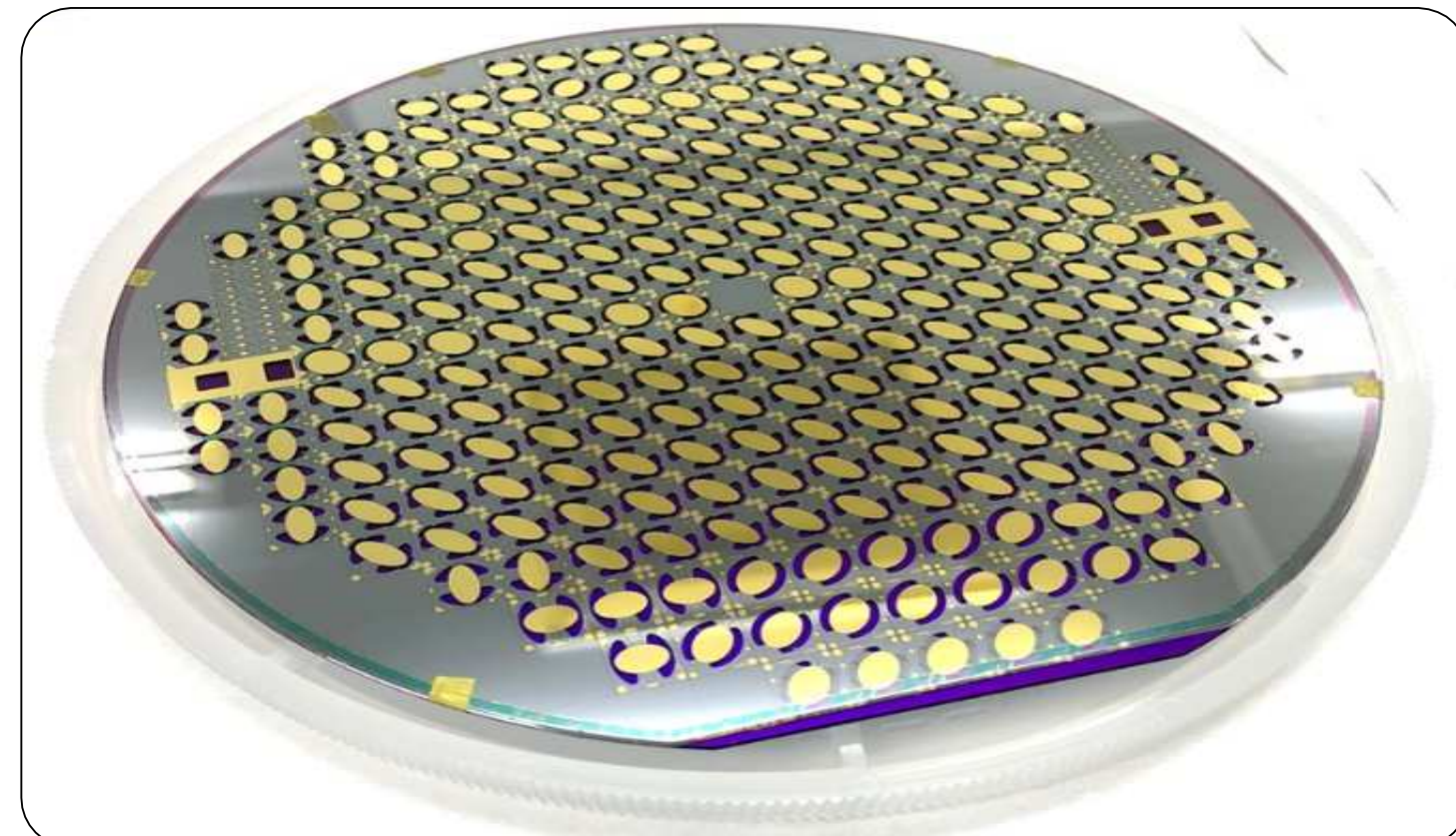
Scan Image

| Parameter | Value |
|-----------------------------|-----------|
| Fast-axis driving (x) [kHz] | 9.5 – 9.7 |
| Slow-axis driving (y) [Hz] | up to 60 |
| Fast-axis TOSA [deg.] | 20 |
| Slow axis TOSA [deg.] | 9 |
| Mirror Size [mm in dia.] | 2 |

* TOSA: Total Optical Scanning Angle [deg.]

Si MEMS Resonant Scanner

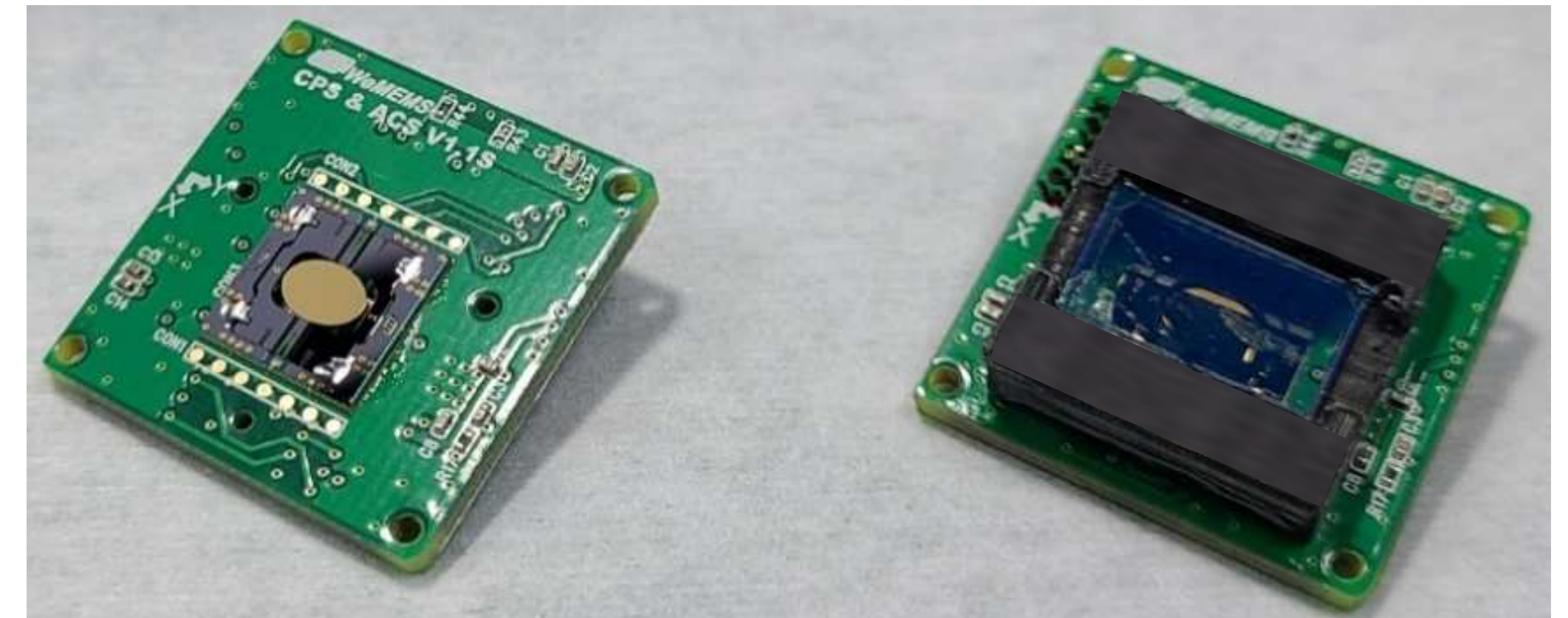
- ✓ Si-based one-axis MEMS scanner chip and packaged module
- ✓ Sensor-embedded scanners and driver boards
- ✓ Scanning solutions to customers' new requirements (within 3~6 months)



Si scanner Chips



Packaged MEMS scanner

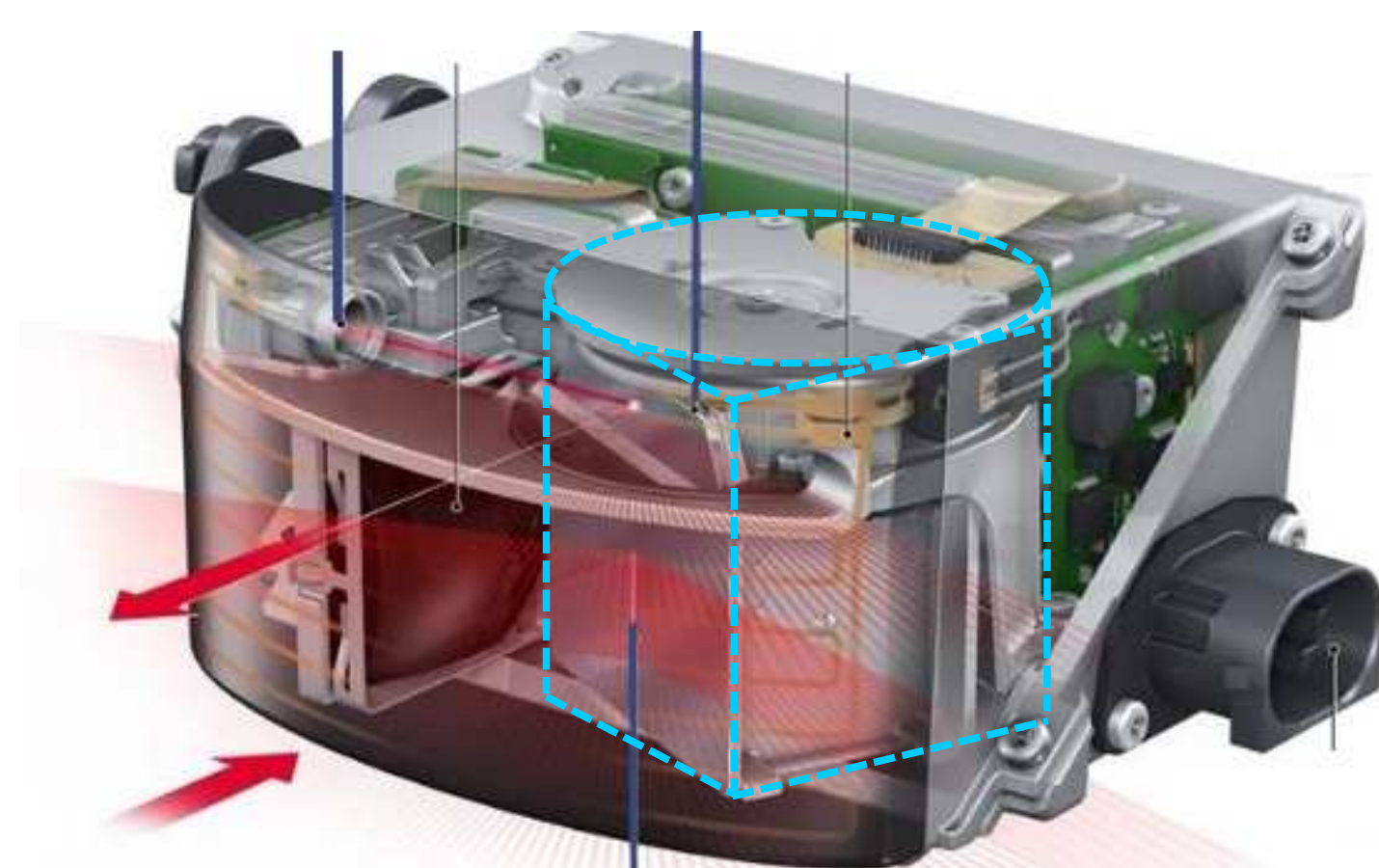


Sensor-embedded resonant scanner

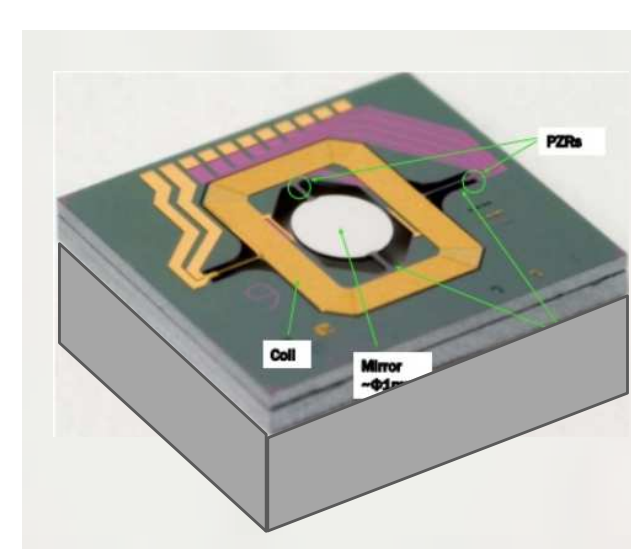
Evolution of Scanning Technology

- ✓ Miniaturization and low price are prerequisite to autonomous vehicle
- ✓ Electrostatic scanner is superior in terms of size, speed, power, reliability & price

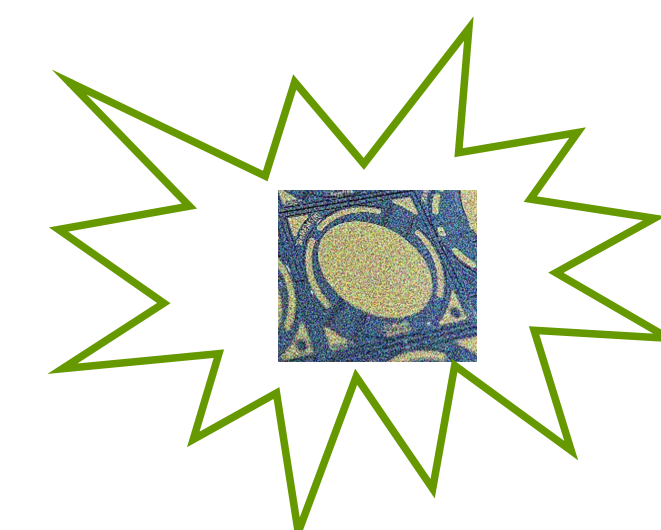
Rotating motor
Assembly (current)



Magnet
assembly (current)



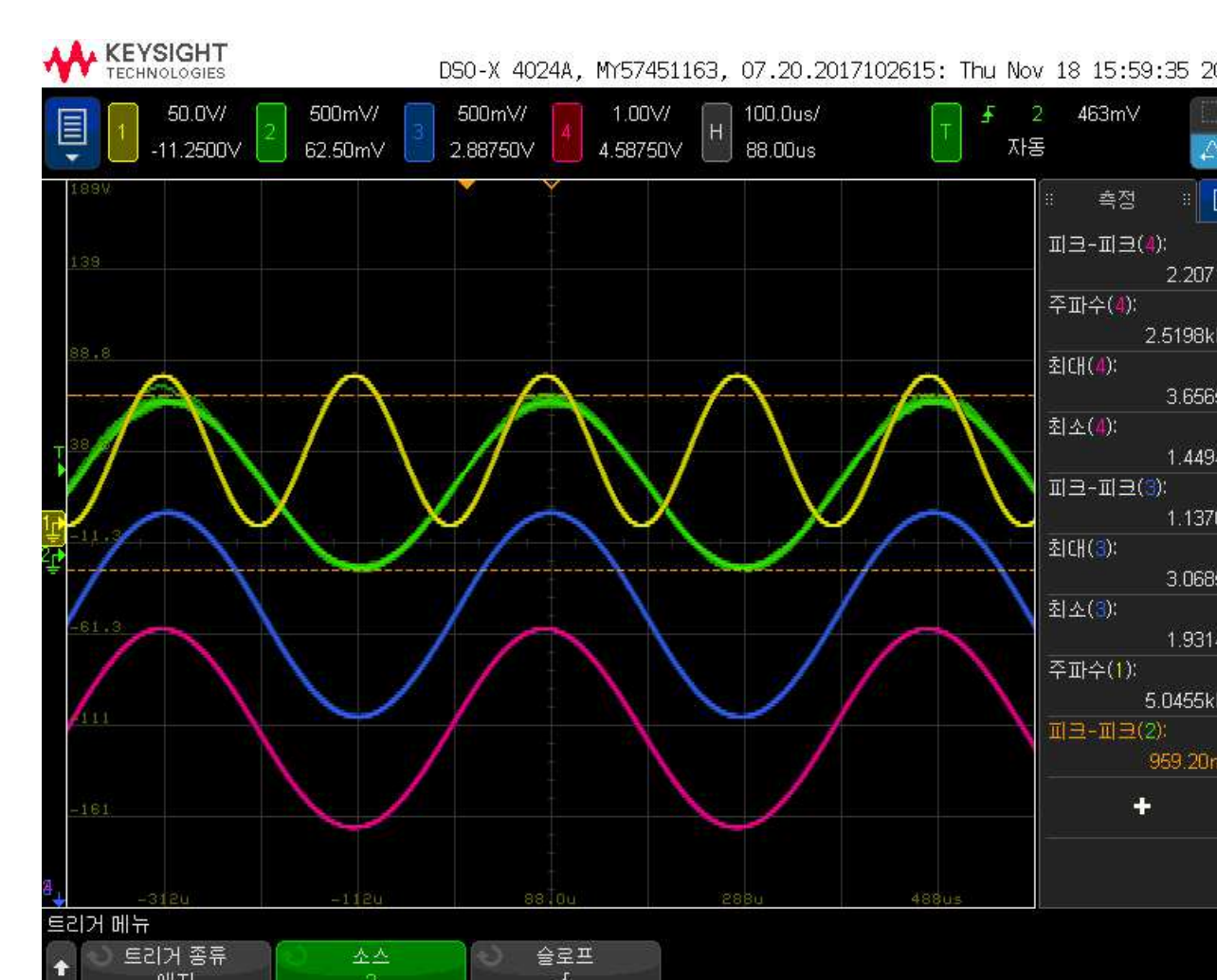
Electrostatic
integrated (voltage)



Experimental Performance



Mirror 2~5 mm dia.
Freq. 2~9 kHz
OSA 25~40°
Sensor embedded

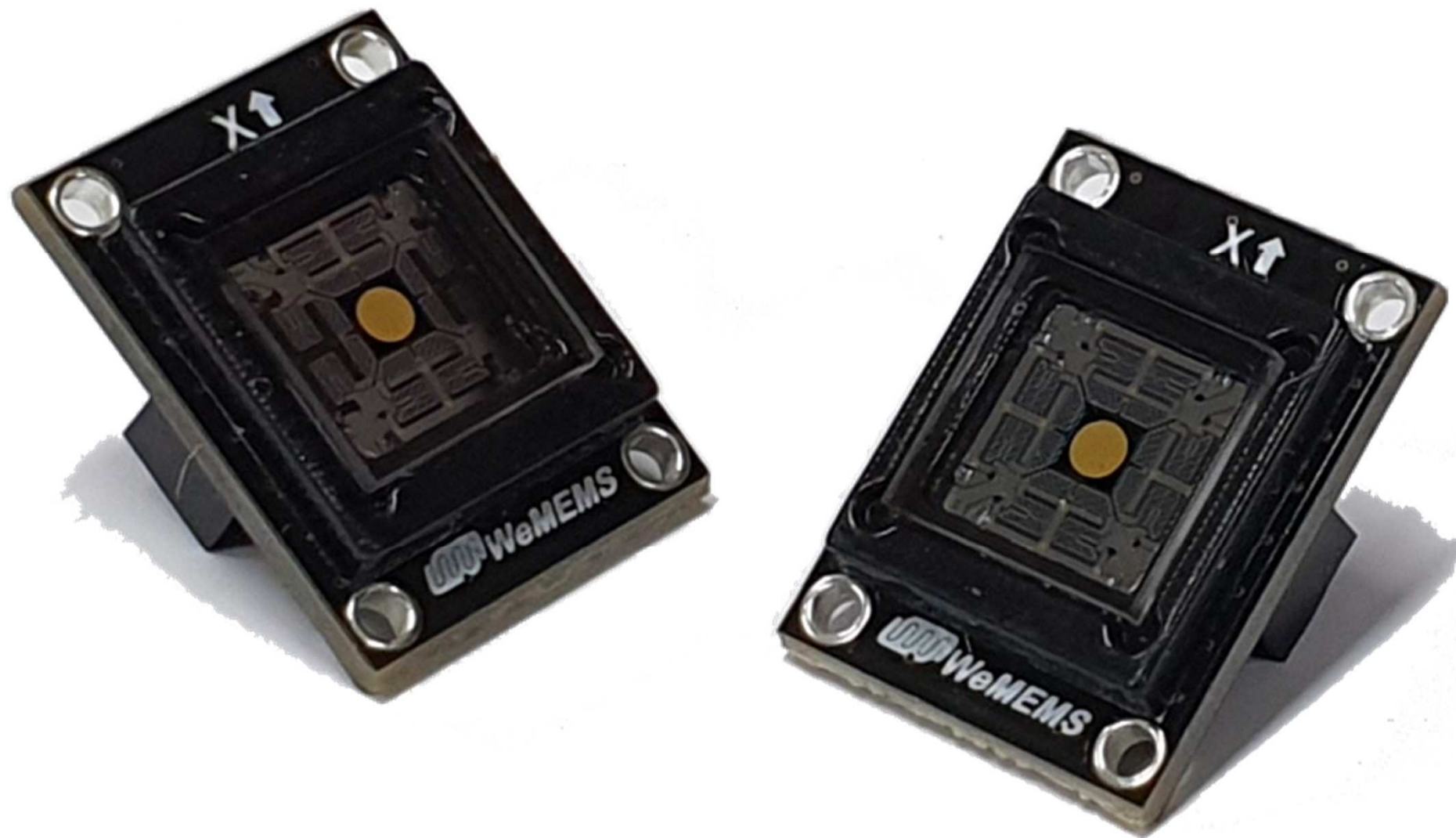


■ Drive
■ PSD (ref)
■ Sense1
■ Sensor

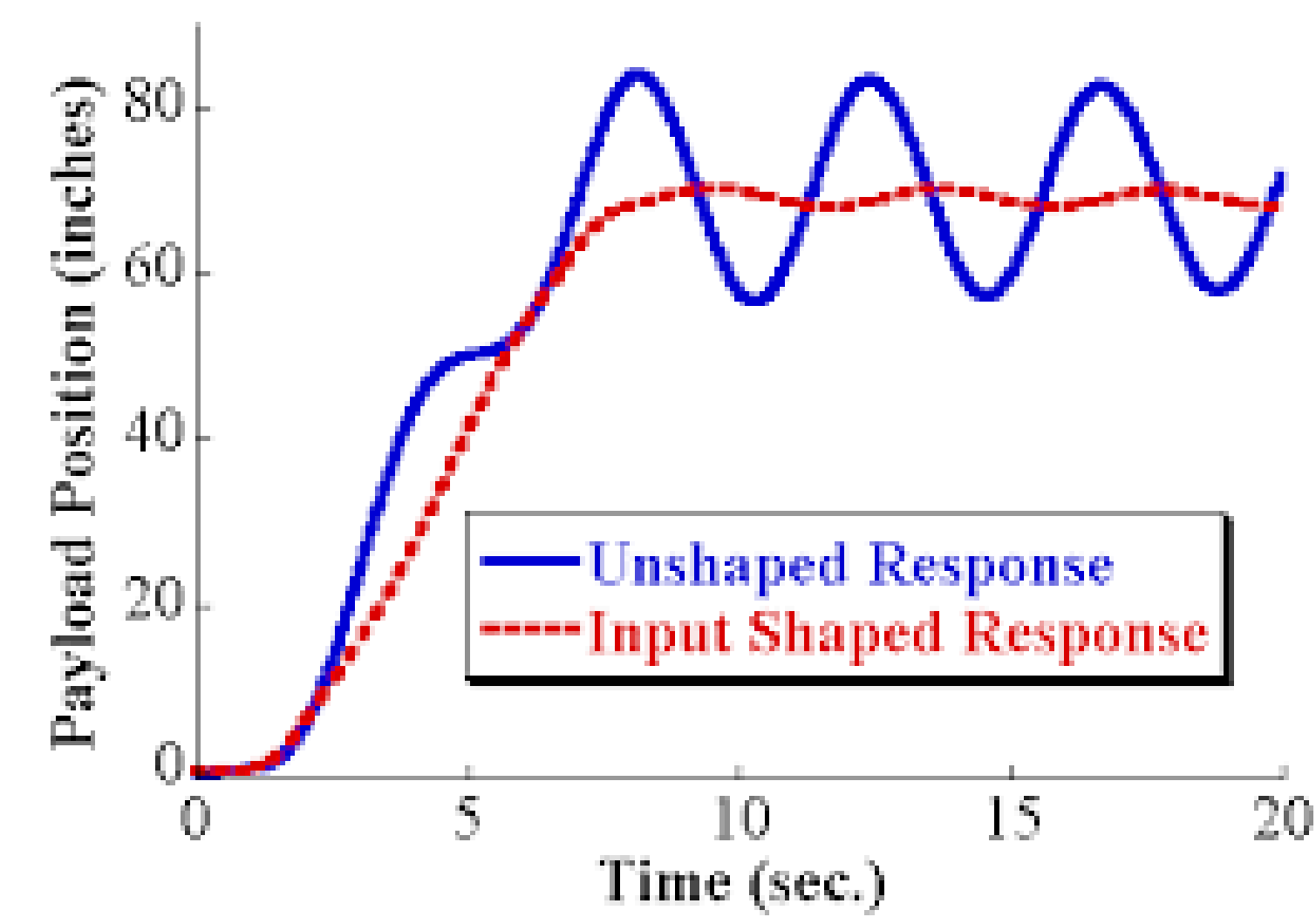
*Parametric oscillation

● Si MEMS Quasi-static Scanner

- ✓ Si-based one-axis & two-axis quasi-static MEMS scanner
- ✓ Arbitrary motion according to driving waveform (Input shaping)



Packaged quasi-static scanner



Input shaping

● Diverse Application Fields

- ✓ Laser scanning for LiDAR, 3D scanning, industrial metrology/inspection
- ✓ Optical projection for AR microdisplay, HUD(Head Up Display), holography
- ✓ Biological applications: endoscopic OCT, medical diagnostics, sample analysis
- ✓ Optical communication etc..

Laser scanning
LiDAR system



Optical projection
Virtual Reality



Biological application
Medical diagnostics

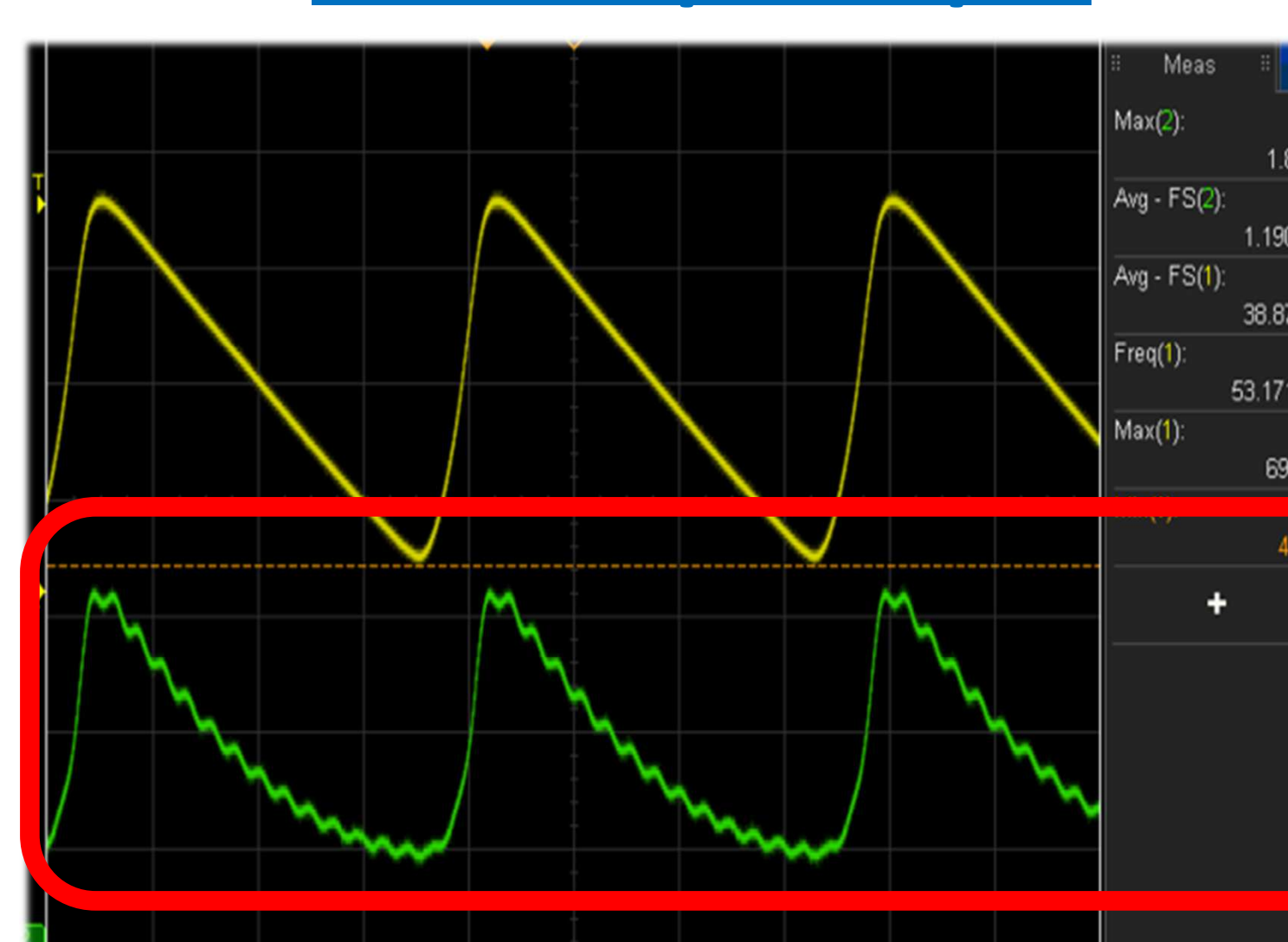


Designed by free pik(user14159562)

● Linearized Motion of Mirror

- ✓ The motion of the scanning mirror is controllable by utilizing input shaping.
- ✓ The mirror motion can be linearized to expand the usable scan range.

Non-shaped input



Shaped input



■ Driving signal

■ PSD (ref)